Hite	Search Ouen	DRs	Default	Plurale	Time Stamp
HILL	Jean Query	003	Operator	riulais	rime stamp
9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR	OFF	2005/05/17 12:43
92	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5)	USPAT	OR	OFF	2005/05/17 12:44
284	359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1	USPAT	OR	OFF	2005/05/17 12:44
4	(("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")). PN.	USPAT	OR	OFF	2005/01/27 11:04
1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 10:48
0	method.ti. and fabricating.ti. and mircromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
3	method.ab. and fabricating.ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
0	method.ti. and fabricate.ti. and micromirror.ti.	USPAT	OR	OFF	2005/01/31 10:50
0	method.ti. and fabricating.ti. and micromirror.ti.	USPAT	OR ·	OFF	2005/01/31 10:50
9	(("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5737052") or ("6348991")).PN.	USPAT	OR ·	OFF	2005/01/31 10:56
5	fabricating ab. and micromirror.ab.	USPAT	OR	OFF	2005/01/31 11:03
1	("20040233500").PN.	US-PGPUB	OR	OFF	2005/01/31 16:28
. 30	("3766205" "4402573" "4853471" "4902108" "5032498" "5140455" "5151816" "5239406" "5457564" "5679283" "5724187" "5770114" "5818636" "5859722" "5910854" "5998617" "6002511" "6020987" "6141137" "6154306" "6183878" "6187845" "6188505" "6193912" "6241916" "6262832" "6277307" "6301038"	US-PGPUB; USPAT; USOCR	OR .	OFF	2005/01/31 18:45
	92 284 4 1 0 3 0 0	9 (("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("5537234") or ("5537234") or ("6348991")).PN. 92 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5) 284 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 4 (("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")). PN. 1 ("20040233500").PN. 0 method.ti. and fabricating.ti. and micromirror.ti. 3 method.ab. and fabricating.ti. and micromirror.ti. 0 method.ti. and fabricating.ti and micromirror.ti. 9 (("4956619") or ("5600383") or ("6038056") or ("5531782") or ("6348991")).PN. 5 fabricating.ab. and micromirror.ab. 1 ("20040233500").PN. 30 ("3766205" "4402573" "4853471" "4902108" "5032498" "5140455" "5151816" "5239406" "5457564" "5679283" "5724187" "5770114" "5818636" "5859722" "5910854" "57998617" "6002511" "67020987" "6141137" "6154306" "6183878" "6187845" "6188505" "6193912" "6141137" "6193912" "6141137" "6193912" "6141137" "6193912" "6187845" "6188505" "6187845" "6188505" "6187845" "61878	9 (("4956619") or ("5600383") or ("6038056") or ("5531782") or ("6413793") or ("5737052") or ("6348991")).PN. 92 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) same stop\$5) 284 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 4 (("6,700,693") or ("6,710,906") or ("6,700,693") or ("6,262,832")). PN. 1 ("20040233500").PN. 0 method.ti. and fabricating.ti. and micromirror.ti. 3 method.ab. and fabricating.ti. and micromirror.ti. 0 method.ti. and fabricating.ti. and micromirror.ti. 1 ("4956619") or ("5600383") or ("673793") or ("673793") or ("6348991")).PN. 5 fabricating.ab. and micromirror.ab. 1 ("20040233500").PN. 2 ("4956619") or ("5600383") or ("6348991")).PN. 5 fabricating.ab. and micromirror.ab. 1 ("20040233500").PN. 30 ("3766205" "4402573" US-PGPUB US-	9 (("4956619") or ("5600383") or ("6038056") or ("5631782") or ("613793") or ("5531782") or ("6348991")).PN. 92 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5) 284 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5) 4 (("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")). PN. 1 ("20040233500").PN. 0 method.ti. and fabricating.ti. and micromirror.ti. 3 method.ab. and fabricating.ab. and micromirror.ti. 0 method.ti. and fabricating.ti. and micromirror.ti. 0 method.ti. and fabricating.ti. and micromirror.ti. 1 ("4956619") or ("5600383") or ("6348991")).PN. 5 fabricating.ab. and micromirror.ab. 1 ("20040233500").PN. 10 USPAT OR USPAT OR USPAT OR USPAT OR USPAT OR 0 USPAT OR 1 USPA	9 (("4956619") or ("5600383") or ("6038056") or ("5631782") or ("6413793") or ("5510915") or ("6413793") or ("5537752") or ("6348991")).PN. 92 359/290,291,292,295,223,224, 245,248,320,332.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$1) and state\$1 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$1 or micromirror\$1) and state\$1 4 (("6,700,693") or ("6,710,906") or ("6,445,486") or ("6,262,832")). PN. 1 ("20040233500").PN. US-PGPUB OR OFF OFF OFF OFF OFF OFF OFF OFF OFF

[C13	1210	#350#/t sels and north? and	USPAT	OR	OFF	2005/05/15 19:24
S12	1218	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1	USPAT	OK	Orr	2003/03/13 19.24
S13	262	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (two with state\$1)	USPAT	OR	OFF	2005/05/16 18:46
S14	124	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (two with state\$1) and angle\$1 and degree	USPAT	OR	OFF	2005/05/16 13:11
S15	91	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with ((polpolycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu))	USPAT	OR	OFF	2005/05/15 22:18
S16	35	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with ((polpolycrystalline near silicon) or (monocrystalline near silicon) or (amorphous near silicon) or Aluminum or Mo or W or (Ti "Si.sub.2") or (Co "Si.sub.2") or ("Ti.sub.N") or Cu)) and (post same (material or made))	USPAT	OR	OFF	2005/05/16 11:24
S17	0	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with (polpolycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S18	o o	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polpolycrystalline near silicon)) and doped	USPAT	OR	OFF	2005/05/16 11:37
S19	0	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (post with (polpolycrystalline near silicon)) and dopped	USPAT	O R	OFF	2005/05/16 11:37
S20	0	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polpolycrystalline near silicon)) ' and dopped	USPAT	OR	OFF	2005/05/16 11:37
521	0	post\$2 and (mirror\$1 or micromirror\$1) and (post with (polpolycrystalline near silicon)) and dopped	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/05/16 11:37
S22	556	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and (state\$1) and angle\$1 and degree	USPAT	OR	OFF	2005/05/16 13:11

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S23	1218	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) stop\$5)	USPAT	OR	OFF	2005/05/16 18:47
S24	241	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and ((mirror\$2 or micromirror\$3) same stop\$5)	USPAT .	OR	OFF	2005/05/17 12:44
S25	115	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1))	USPAT	OR	OFF	2005/05/16 21:59
S26	1	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1)) and (semiconductor with dioxide)	USPAT	OR	OFF	2005/05/16 22:32
S27	34	"359"/\$.ccls. and post\$2 and (mirror\$1 or micromirror\$1) and state\$1 and (mirror\$2 or micromirror\$3) and (semiconductor\$2 with (micromirror\$ or mirror\$1)) and (silicon with dioxide)	USPAT	OR	OFF	2005/05/17 12:10